

JFM



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Albert Birner et al.

Art Unit : 2822

Serial No. : 10/630,373

Examiner : Thanh Y. Tran

Filed : July 30, 2003

Title : SEMICONDUCTOR TRENCH STRUCTURE

Mail Stop Amendment

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

REPLY TO ACTION OF SEPTEMBER 28, 2004

Please amend the above-identified application as follows:

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

December 28, 2004

Date of Deposit

Signature

Irja Zarembok

Typed or Printed Name of Person Signing Certificate